

Methane Formation on H₂ Purification Using a Commercial Pd-Ag Membrane

T. H. Hsiung, D. D. Christman, E. J. Hunter, and A. R. Homyak

Electronics Div., Air Products and Chemicals, Inc., Allentown, PA 18195

Hydrogen is being used in many semiconductor manufacturing steps as a reactant or as a carrier gas. Examples of these process steps are silicon epitaxy, doping of boron, and chemical vapor deposition (CVD) of tungsten metal. In many of these processes, ultrahigh-purity (UHP) hydrogen is required to ensure the desirable properties of the semiconductor product.

UHP H₂ can be generated in different ways. In places where liquid H₂ is readily available, UHP H₂ can be obtained by "vapor withdrawal" in that only the vapor phase of the H₂ is taken from a liquid H₂ storage tank. No purifier is needed. Homyak et al. (1995) demonstrated that vapor H₂ gas from a liquid source contained impurities with concentrations well below parts-per-billion (ppb) levels. Presumably, all impurities were trapped in the liquid H₂, since H₂ has the lowest boiling point (except for helium) of all gases. In areas where only pipeline gaseous H₂ is available, such as most of Asia, purification is required to remove impurities such as N₂, O₂, CO, CO₂, CH₄, and H₂O.

One common commercial H₂ purifier uses a Ag-Pd alloy membrane. This precious-metal-based membrane purifies H₂ by a mechanism in which the H₂ transports through the non-porous membrane as protons. After diffusing through the membrane, the protons recombine (with electrons) to form H₂ molecules. This mechanism should exclude impurities from permeating through the membrane. The H₂ permeability of the Ag-Pd membrane increases with increasing temperature. For the membrane to be cost-effective, the operating temperature for the membrane is usually between 350 and 450°C.

Recently, in an effort to qualify a commercial Ag-Pd membrane purifier for a customer in the electronics industry, we discovered that CO and CO₂ in the feed hydrogen can result in traces of CH₄ in the purified product. The formation of CH₄, even in trace levels, disqualifies the product for the customer. This specific customer requires a CH₄ concentration to be less than 10 ppb by volume (ppbv) in hydrogen. For CH₄ to form, carbon has to be present in some form. We

hypothesized that CO and CO₂ decomposed to C and O on the membrane surface, and that C diffused across the membrane and then reacted with the product H₂ to form CH₄.

Carbon transportation through a Pd membrane has been reported in the literature. For instance, Ziemecki (1987) demonstrated a catalytic water-gas shift reaction resulting from C diffusion across a Pd membrane. Ethylene was used as the carbon source. Apparently, ethylene decomposed on one side of the membrane to C and H₂, and C diffused through Pd membrane to react with the water vapor on the other side.

This note presents experimental evidence of CH₄ formation from a commercial Ag-Pd membrane on the product side as a result of CO and CO₂ present on the feed side.

Equipment Setup

The experimental setup is shown in Figure 1. The purifier was supplied by Johnson-Matthey using a standard commercial Ag-Pd membrane about 120 μm thick.

The designed flow of this purifier is 14.9 m³/h (422 std. ft³/h) at 1,723 kPa (250 psig) inlet pressure and 689 kPa (100 psig) outlet pressure. The purifier has a bleed rate of 2 L/min. Hydrogen was supplied by a bank of HydriL Tubes. Impurities were added using a Challenge Gas Cylinder where impurities were blended.

Analytical Process

Accurate analysis of the feed gas and the product gas was a critical part of the experiment. To analyze the inlet gas, three analyzers were used. A Trace Gas Analyzer Model 4000 made by Valco Instruments was used to measure the concentrations of CO, CO₂, N₂, and CH₄. The Valco analyzer was a gas chromatograph equipped with a helium ionization detector capable of detecting the impurities at the ppbv level (Maroulis and Martinez de Pinillos, 1985). A Meeco Aquamatic Plus analyzer was used to determine the water content. The detectable limit of the Meeco analyzer was around 10 ppbv (Zatko and Ragsdale, 1988). The O₂ level was quantified by an Osaka MK III/Y analyzer with a sensitivity of 2

Correspondence concerning this article should be addressed to T. H. Hsiung.

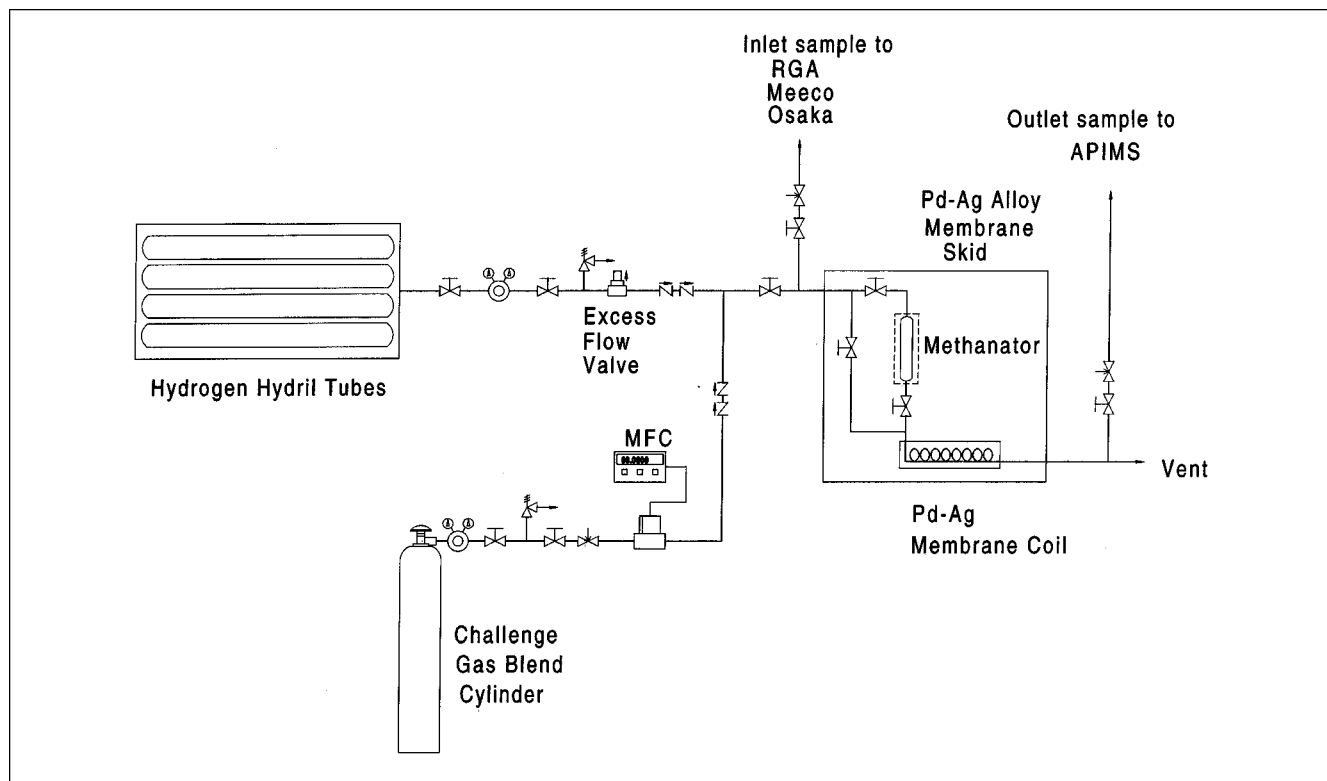


Figure 1. Test apparatus.

ppb by volume. The product stream was continuously monitored by a VG APIX Atmospheric Pressure Ionization Mass Spectrometer (APIMS). APIMS has been shown to be able to detect all these impurities at levels below ppbv in H_2 (Homyak et al., 1995; Sugiyama et al., 1988).

Results

The experimental system was first purged with purified hydrogen until all impurities in the product were below 10 ppbv, analyzed by APIMS. Several experiments were conducted using different challenges.

Challenge with CO , CO_2 , and CH_4

The hydrogen was then spiked with 60 parts-per-million by volume (ppmv) of CO , 60 ppmv CO_2 , 60 ppmv CH_4 , and 1200 ppmv N_2 . The purifier temperature was at $350^\circ C$. After about 30 min, the impurity challenge was reduced to a more realistic level of 20 ppmv CO , 20 ppmv CO_2 , 20 ppmv CH_4 , and 400 ppmv N_2 . The product stream was continuously monitored by the APIMS during the impurity challenge.

Figure 2 shows the results from the APIMS. While no other impurities were observed in the purified H_2 stream, CH_4 started to elute after about 95 min from when the first challenge was introduced. In an additional 95 min, the CH_4 concentration increased gradually from 4 ppbv to above 10 ppbv, when the challenge was shut off. Methane continued to form for several hours after the termination of the challenge. Water and oxygen in the product, however, remained constant at

around 2 ppbv. At the end of the experiment, a temperature increase from 350 to $400^\circ C$ increased the CH_4 concentration in the product.

Another experiment was conducted with lower impurity concentrations. After the membrane cell was purged at $400^\circ C$, the cell temperature was reduced to $350^\circ C$ and the membrane was challenged with 5 ppmv each of CO , CO_2 , CH_4 , and 100 ppmv N_2 . The APIMS result on the product hydrogen stream is shown in Figure 3.

Approximately 90 min after the challenge, the CH_4 concentration in the product started to climb slowly. The concentration increase continued for more than 10 h, and an equilibrium was not reached. Again, the water and the oxygen concentrations did not increase with the increase of CH_4 .

A series of experiments was then performed to identify the source of the CH_4 .

Challenge with CH_4 only

"Can CH_4 transport through the membrane?" is an obvious question to ask. To test whether CH_4 could transport through the membrane, we challenged the purifier with hydrogen containing only methane. First, the Pd membrane was purged with purified H_2 at $400^\circ C$ and then reduced to $375^\circ C$. All impurities in the product H_2 were below 10 ppbv before the challenge. We started the challenge with 25 ppmv CH_4 , with no other impurities added. The purifier temperature was maintained at $375^\circ C$. The CH_4 challenge lasted for more than 6 h. The product H_2 was monitored by the APIMS, and the results are presented in Figure 4.

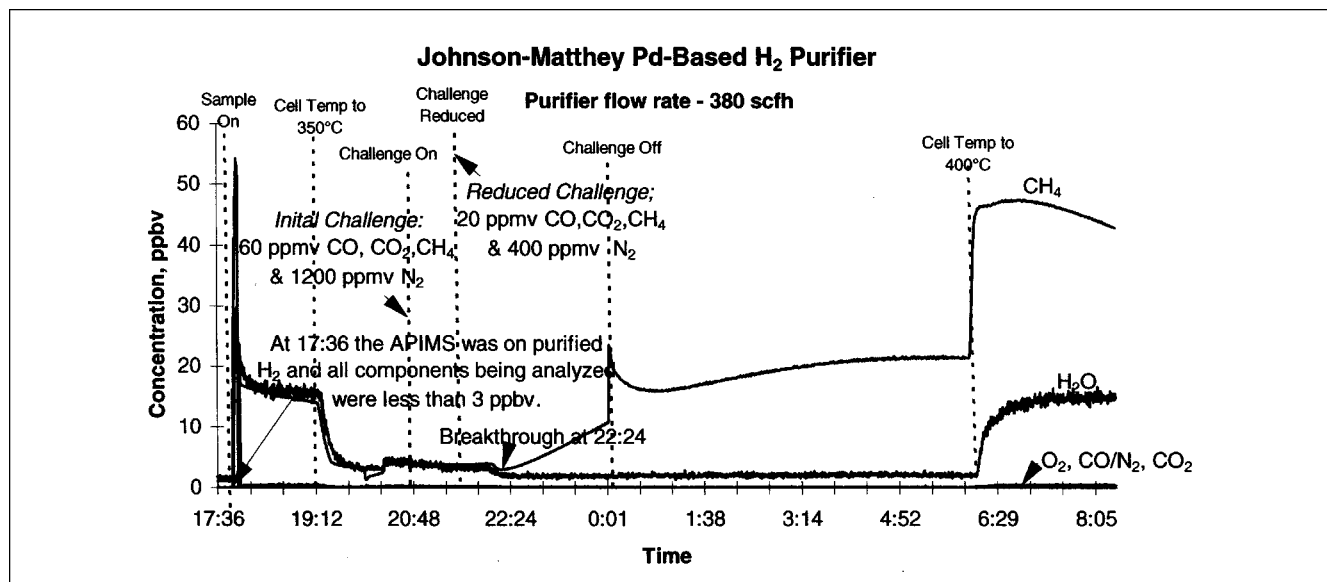


Figure 2. APIMS result on challenge containing CO, CO₂, CH₄, and N₂.

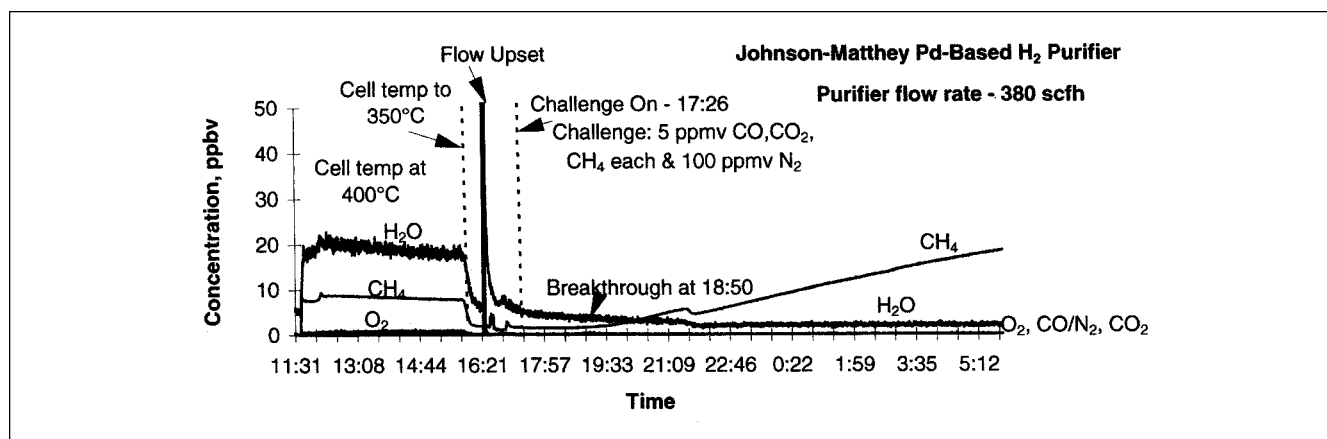


Figure 3. APIMS result on low concentration challenge.

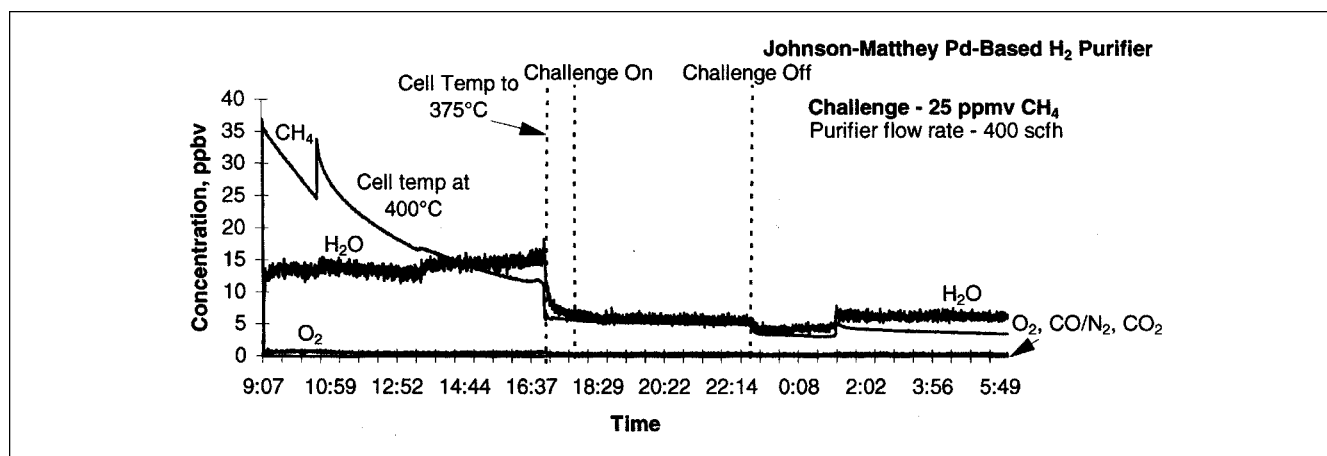


Figure 4. APIMS result on challenge containing only CH₄.

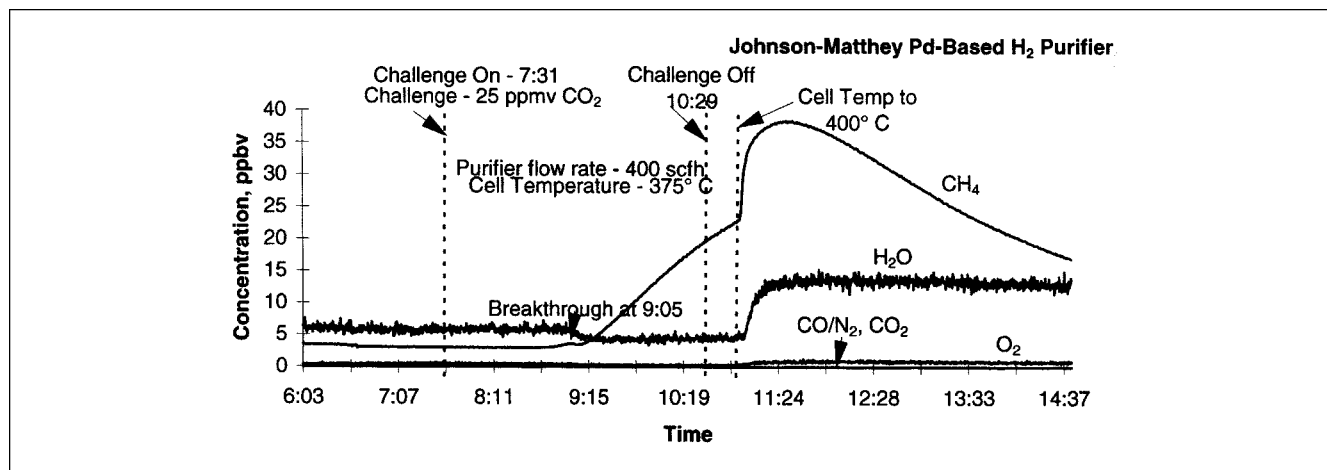


Figure 5. APIMS result on challenge containing only CO₂.

Methane in the H₂ product remained stable and well below the target 10 ppbv level, suggesting that CH₄ in the feed did not affect the purity in the product. There was a drop of CH₄ from 5 ppbv to 4 ppbv over a period of approximately 2 h after the challenge was turned off. No apparent reason can be offered for this phenomenon.

Challenge with CO₂ only

To further investigate the CH₄ formation, we challenged the purifier with only CO₂. After the system was purged to ensure that CH₄ was below 10 ppbv, CO₂ was added to produce a feed concentration of 25 ppmv. The membrane cell was set at 375°C. Figure 5 shows the APIMS data.

About 95 min after the introduction of CO₂, the CH₄ concentration in the product started to increase, while the H₂O and O₂ levels remained stable. In another 85 min, the CH₄ concentration reached 20 ppbv, and the CO₂ challenge was turned off. The CH₄ concentration in the purified H₂ continued to increase. We then raised the cell temperature to 400°C to expedite the cleaning of the membrane. The rate of methane elution increased initially, but it leveled off relatively quickly when the CH₄ concentration reached approximately 38 ppbv. The CH₄ continued to elute for many hours after the CO₂ source was shut off.

Test with methanation catalyst

The preceding experiments suggested that CO₂ and probably CO were the source of CH₄, and that CH₄ in the feed did not contribute to CH₄ in the product. Hence, one logical solution to prevent the CH₄ formation is to convert CO₂ and CO to CH₄ before they pass through the Pd-Ag membrane. An experiment was performed to verify the hypothesis.

The test setup shown in Figure 1 was modified to include a methanation unit installed upstream of the membrane cell. The methanation unit was charged with a commercial methanation catalyst capable of converting CO and CO₂ to CH₄ and H₂O at a temperature of 300°C or higher. The system was challenged with a stream containing CO, CO₂, CH₄, and

N₂. The product purity was again monitored by APIMS, and the result is summarized in Figure 6.

The experiment was started with the methanator on-line. After the system was purged to show that all impurities were below 10 ppbv, the purifier was challenged with 350 standard ft³/h H₂ flow containing 20 ppmv each of CO, CO₂, CH₄, and 400 ppmv N₂. The inlet pressure was at 170 psig and the cell temperature was set at 375°C. For over 3 h, the CH₄ concentration in the product remained constant at a level of approximately 1 ppbv. Some process-variable variations were made, and the responses are shown in the figure. Only small changes (< 2 ppbv) of CH₄ concentration were noted in all process-variable variations.

Discussion

Over a commercial Pd-Ag membrane, the preceding experiments demonstrated the formation of traces of CH₄ when the H₂ feed contained CO₂. Methane, however, does not transport through the membrane. The water and the oxygen concentrations did not increase with the evolution of CH₄, which suggests that O does not transport through the membrane.

In view of data obtained in this study, a plausible mechanism of methane formation in the commercial Pd-Ag alloy membrane might consist of the following steps:

1. Adsorption of CO and CO₂ on the membrane surface;
2. Decomposition of CO and CO₂ on the surface to form C and O;
3. Hydrogen reacts with O to form H₂O;
4. A small portion of the C transport through the membrane via solid phase diffusion;
5. Product H₂ reacts with C to form CH₄;
6. Desorption of CH₄ into product H₂.

The data showed that the CH₄ formation occurred approximately 90 min after the challenge. This slow formation process suggests that Step 4, the solid-phase diffusion, is the rate-determining step. Higher temperatures increased the rate of CH₄ formation.

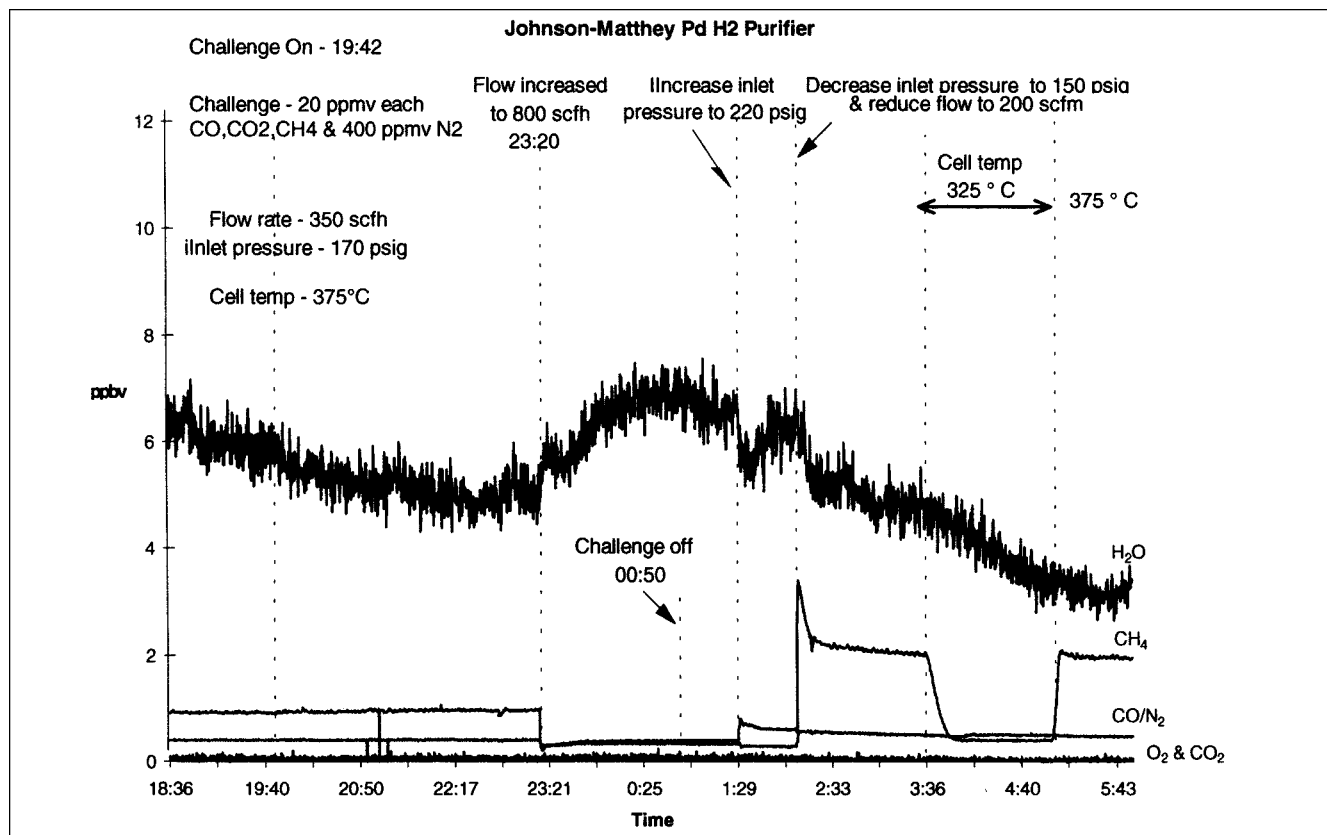


Figure 6. APIMS result with an upstream methanator.

We did not thoroughly study the effects of process variables such as concentration, temperature, and pressure. Additional experiments can be performed to better understand the methane formation.

Conclusion

From the use of highly sensitive analytical equipment, APIMS, we detected trace CH_4 in the product of a commercial Pd-Ag membrane-based hydrogen purifier. Methane formation at ppbv levels was observed when the feed contained ppmv levels of CO and/or CO_2 . We hypothesized that CO and CO_2 decomposed on the metal surface to form C, which then transported through the alloy membrane and reacted with the product H_2 to form CH_4 . Methane in the feed was stable at the operating temperature range of 350°C to 450°C , and hence was successfully excluded by the membrane.

The problem of methane formation in a Pd-membrane-based purifier can be prevented by installing a methanator before the purifier. The methanator converts the CO and CO_2 in the feed to methane and thereby eliminates the carbon formation. The carbon is believed to be the precursor for the methane in the product.

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